Attorney's Docket No.: 09712-251003 / Z-462

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Henry A. Hill Art Unit: 2878

Serial No.: 10/603,116 Examiner: Stephone B. Allen

Filed : June 24, 2003

Title : INTERFEROMETRIC STAGE METROLOGY SYSTEM

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JUNE 29, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

9-29.09

Date of Deposit

Cheyl G. Cam

Signature

CHERYL A. CARON

Typed or Printed Name of Person Signing Certificate